

**METHOD OF ELIMINATING POINT DEFECTS INCLUDED WITHIN AN
ELECTROCHEMICAL DEVICE**

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ABSTRACT

Method of eliminating, using a beam of laser radiation, defects lying within a laminate formed from at least a first substrate and from at least a second substrate, said laminate incorporating, between said first and second substrates, at least one "smart" active system.

This method consists of:

- a phase of locating at least one defect lying within the active system; and
- a phase of ablating the defect, consisting in circumscribing the latter using said laser beam.